

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Conf. No. 5779

Wolfgang STOLZ et al.

Art Unit: 2826

Application No.: 10/580,653

Examiner: Quinto, K.

Filed: March 30, 2007

Attorney Dkt. No.: 12007-0074

For: METHOD FOR PRODUCING OPTICALLY PUMPED SEMICONDUCTOR DEVICES FOR  
THE GENERATION OF RADIATION AND STRAIN COMPENSATION IN THE LAYER  
SUCCESSIONS USED WITHIN (AS AMENDED)

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 6, 2010, a petition for a one month extension of time is made. Payment is addressed at the end of this filing. Please revise the application as follows: